

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE (Case No. 213.007-US)

STEINBERG

In the Application of: YE ET AL.

Serial No: 10/815,573

Filed: APRIL 1, 2004

Title: SYSTEM AND METHOD OF LITHOGRAPHY

SIMULATION

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Group Art Unit: 1756

Before Examiner:

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office, Fax No. (703) 872-9306 on

(name of person signing certificate)

STATEMENT OF RELATED APPLICATION

Dear Sir:

The above-referenced application is also related to the following application:

1. "System and Method of Lithography Simulation", Serial No. 11/084,484, filed March 18, 2005 (still pending).

Notably, this Statement of Related Application supplements the Statement of Related Applications filed on February 3, 2005.

Date: April 25, 2005

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Respectfully submitted,